INTERNATIONAL GEMOLOGICAL INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

October 27, 2026

IGI Report Number	LG852644335
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	PRINCESS CUT
Measurements	5.42 X 5.34 X 3.87 MM

GRADING RESULTS

Carat Weight	1.02 CARAT
Color Grade	E
Clarity Grade	VVS 2
Cut Grade	VERY GOOD

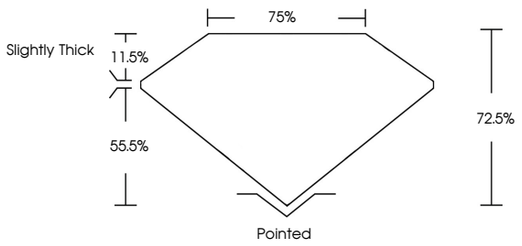
ADDITIONAL GRADING INFORMATION

Polish	VERY GOOD
Symmetry	VERY GOOD
Fluorescence	NONE
Inscription(s)	LG852644335

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG852644335
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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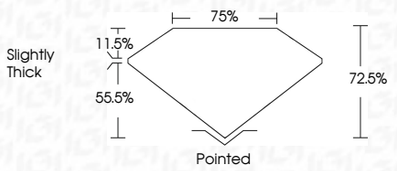
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www.igi.org

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IGI

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PRINCESS CUT
5.42 X 5.34 X 3.87 MM
Carat Weight 1.02 CARAT
Color Grade E
Clarity Grade VVS 2
Cut Grade VERY GOOD
Depth 72.5%
Table 75%
Girdle Slightly Thick
Culet Pointed
Polish VERY GOOD
Symmetry VERY GOOD
Fluorescence NONE
Inscription(s) LG852644335
Comments:
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Type IIa